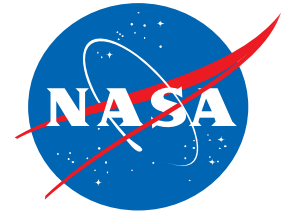


National Aeronautics and Space Administration



Heavy Ion Microbeam- and Broadbeam-Induced Current Transients in SiGe HBTs

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Acknowledgement

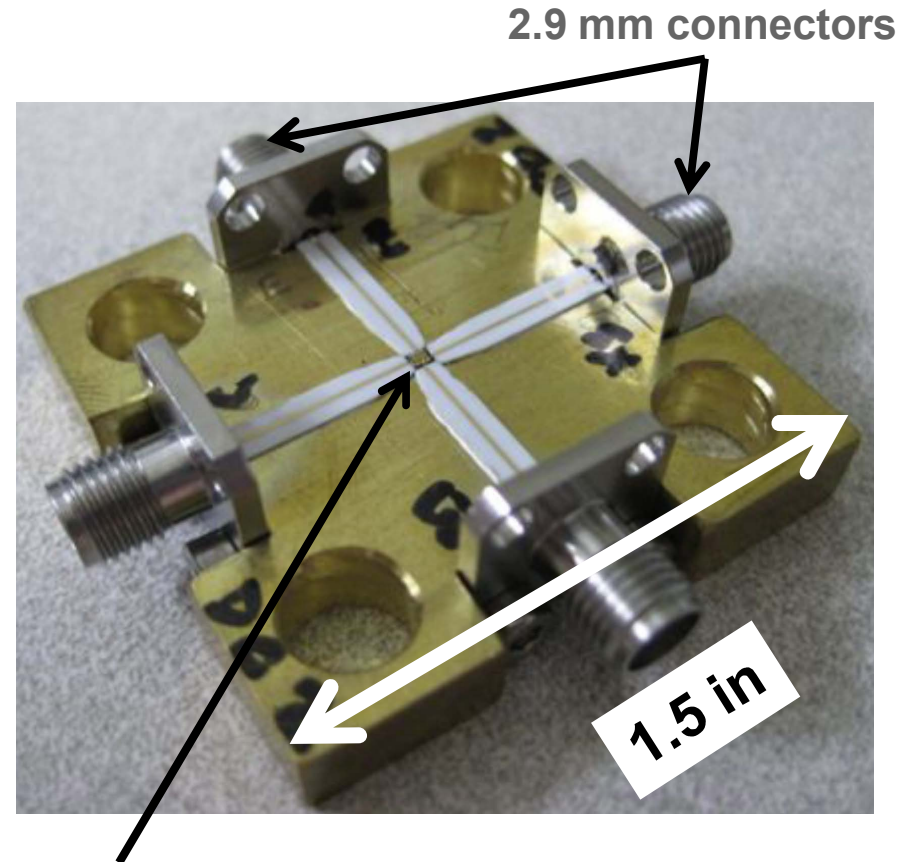
- NASA Electronic Parts and Packaging program
- NASA Radiation Hardened Electronics for Space Environments project
- DTRA Radiation Hardened Microelectronics program under *IACRO #08-4343I* to NASA
- AFOSR MURI program and AFOSR DURIP award
- SiGe teams at the Georgia Electronic Design Center and IBM
- Naval Research Laboratory
- CEA/DIF (Arpajon, France)

- Sandia National Laboratories (SNL)
- Department of Physics at the University of Jyväskylä, Finland (JYFL)
- Grand Accélérateur National d'Ions Lourds, France (GANIL)

Heavy ion transient overview



- IBM 5AM SiGe HBT is device-under-test
- High-speed measurement setup
- Low-impedance current transient measurements
 - SNL, JYFL, GANIL
- Microbeam to broadbeam position inference
- Improvement to state-of-the-art



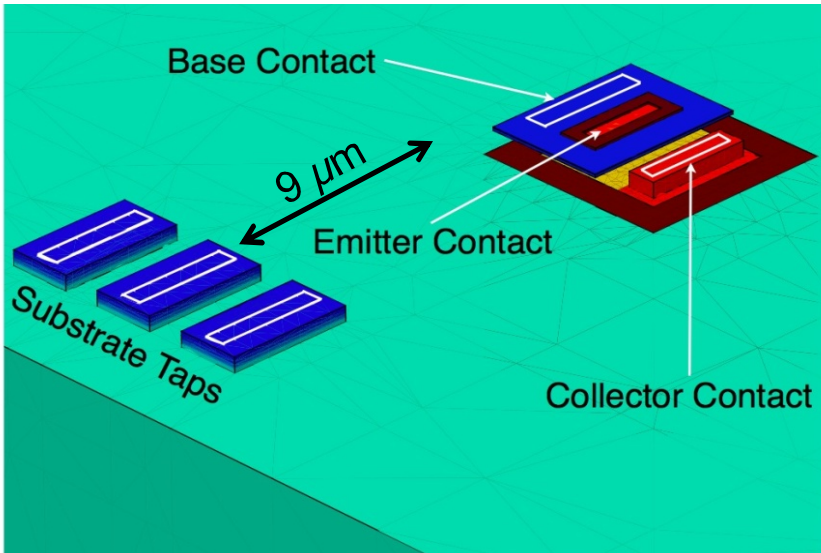
Single SiGe HBT device under test (1 mm²)

R. S. Wagner, *et al.*, *IEEE Trans. Nucl. Sci.*,
vol. 33, no. 6, pp. 1651–1655, Dec. 1986.

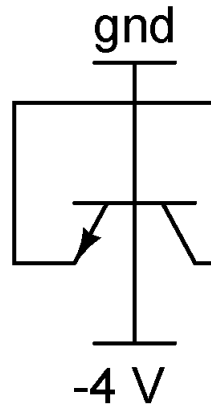
Bias conditions of interest



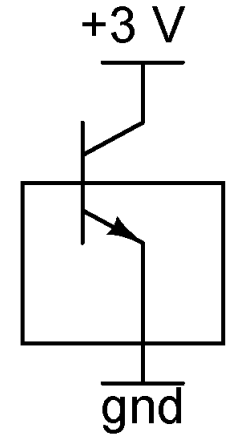
All biases based on device isolation



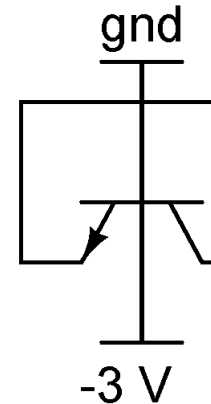
3-D TCAD from DUT GDSII
IBM 5AM npn SiGe HBT



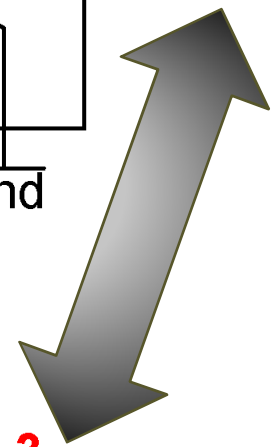
Case 1



Case 2



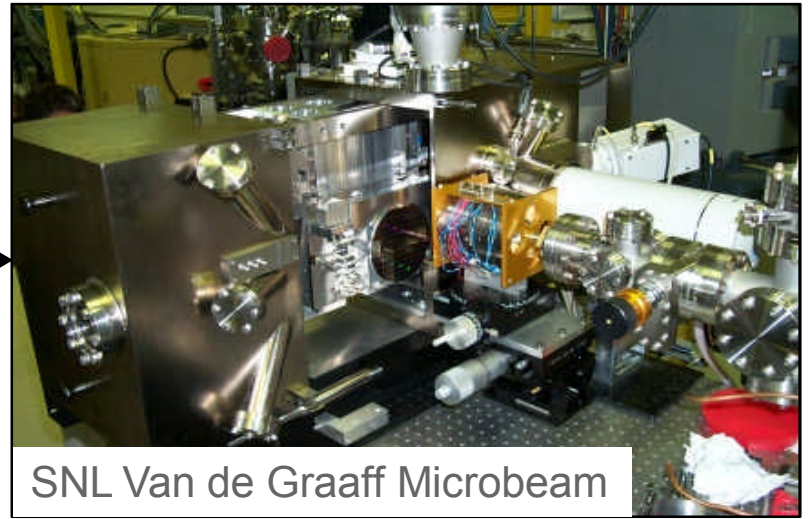
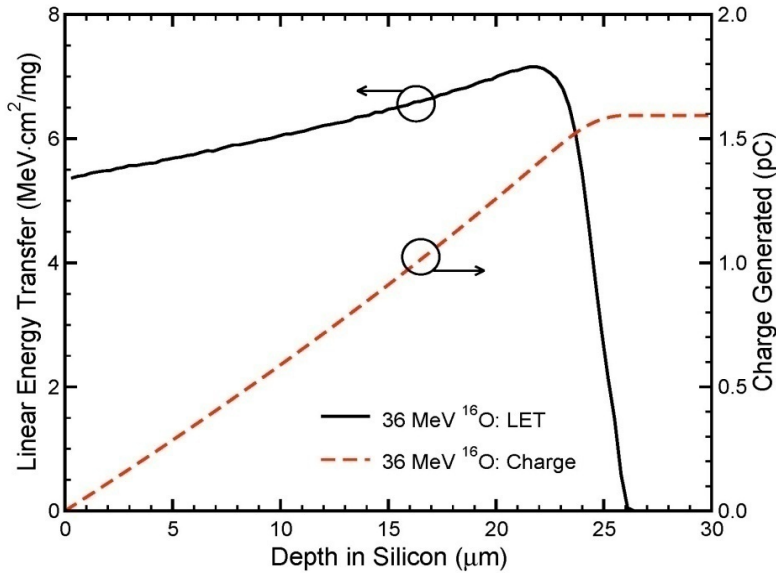
Case 3



Bias conditions chosen to represent “circuit-like” experiments

Typical experimental setup

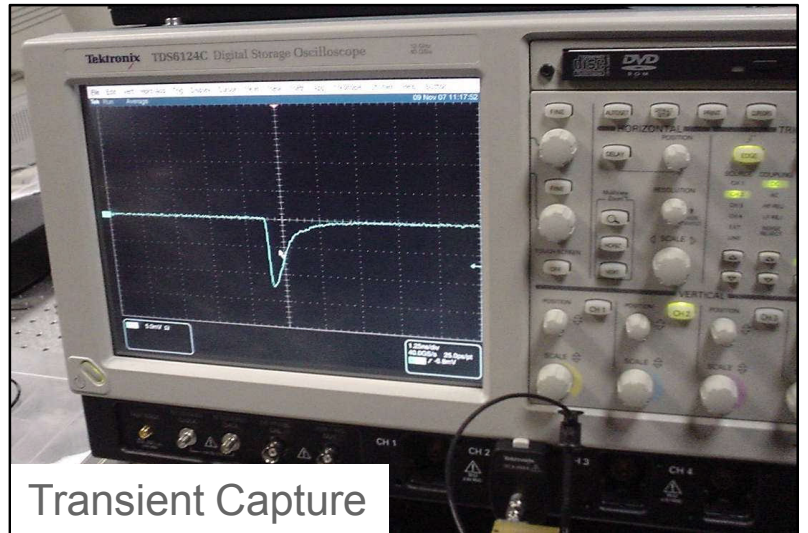
Different than broadbeam



SNL Van de Graaff Microbeam

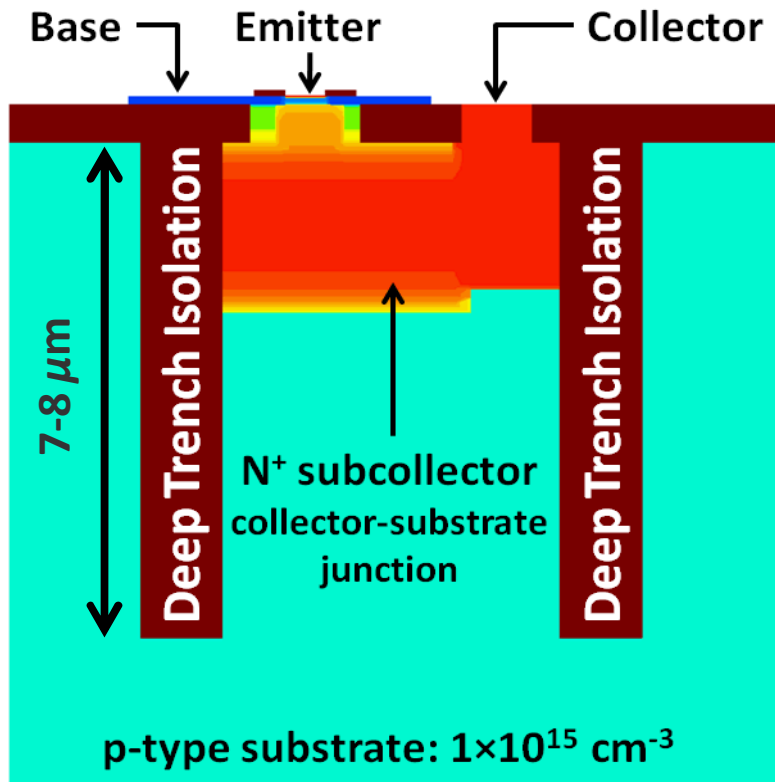
36 MeV ¹⁶O dE/dx profile
[SRIM-2008]

Sandia National Laboratories'
Microbeam Chamber



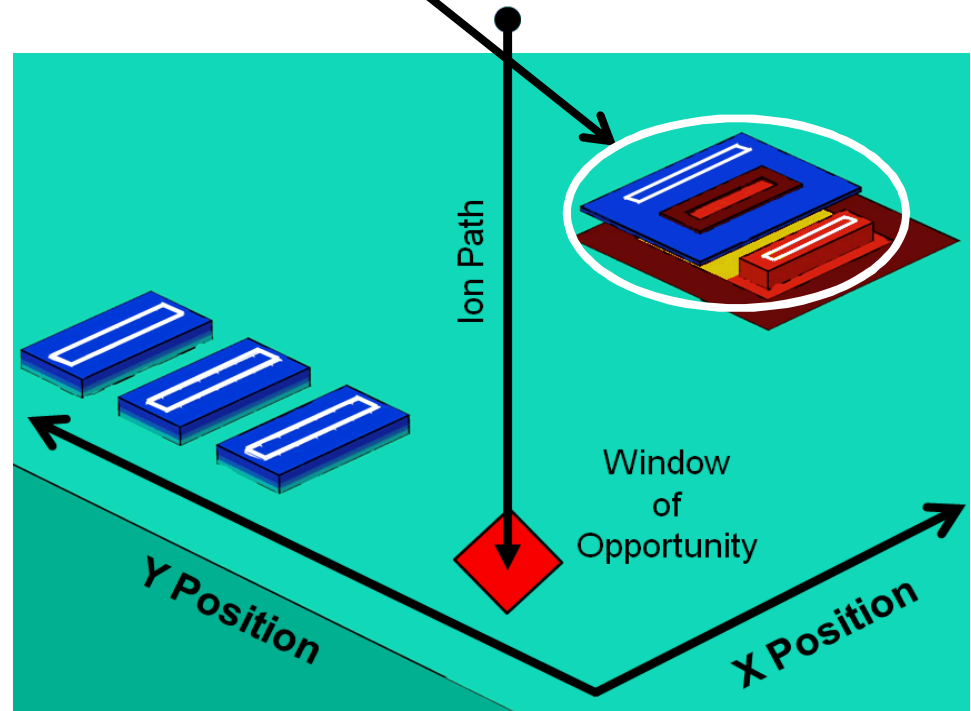
Transient Capture

Device under test and microbeam irradiation



IBM 5AM npn SiGe HBT

Active junction area
Microbeam rastering concept



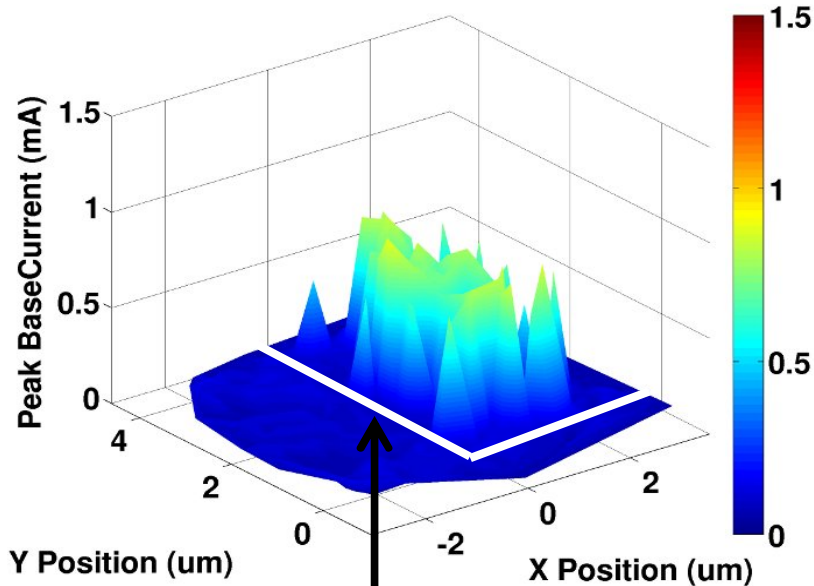
Microbeam data allows position correlation

36 MeV ^{16}O SNL microbeam: Case 1

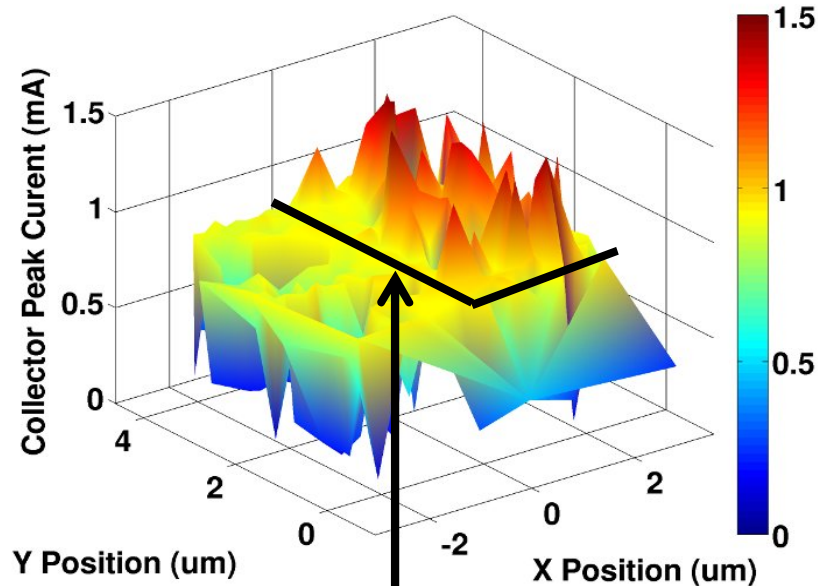


Peak current magnitude

Base



Collector



Active base-collector junction area

- $V_{\text{sub}} = -4 \text{ V}$; all other terminals grounded
- Base terminal images base-collector junction
- Collector terminal images base-collector junction and subcollector

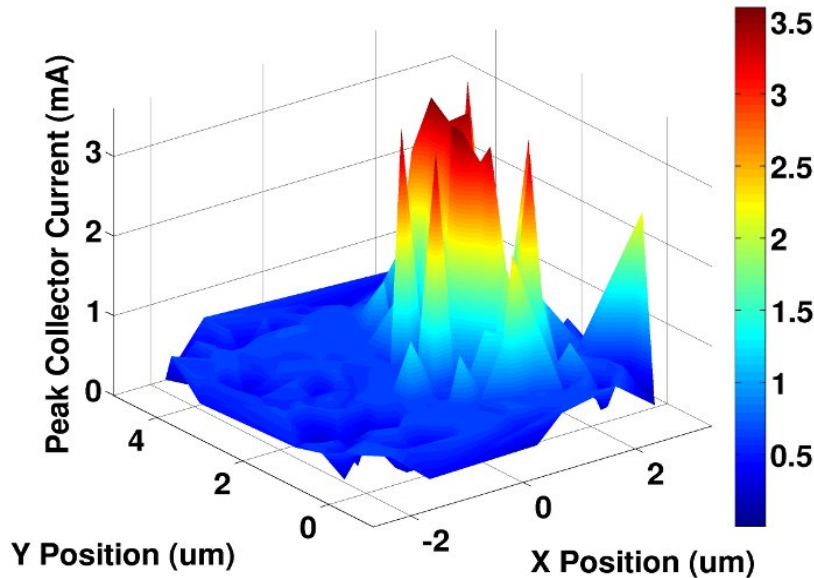
Imaging provides information about position and current

36 MeV ^{16}O SNL microbeam: Case 2 vs. 3

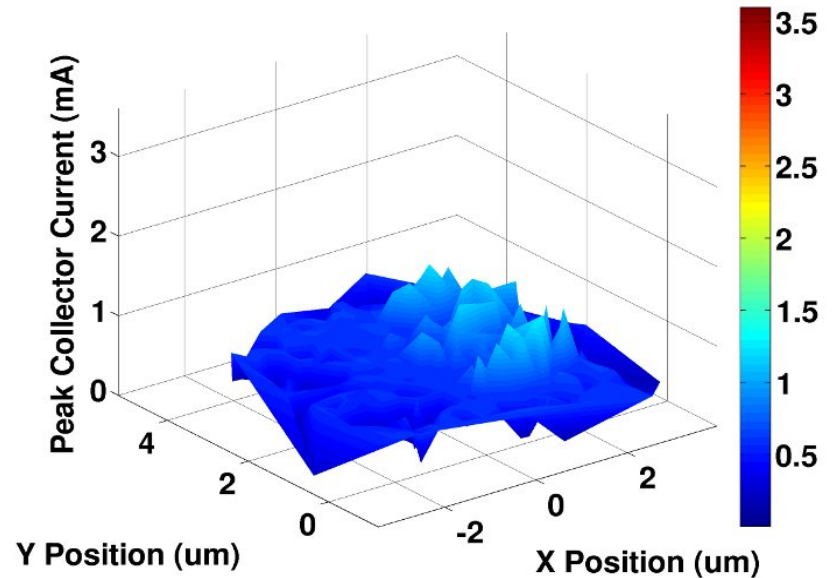


Peak current magnitude

Collector



Collector



$$V_C = +3 \text{ V (Case 2)}$$

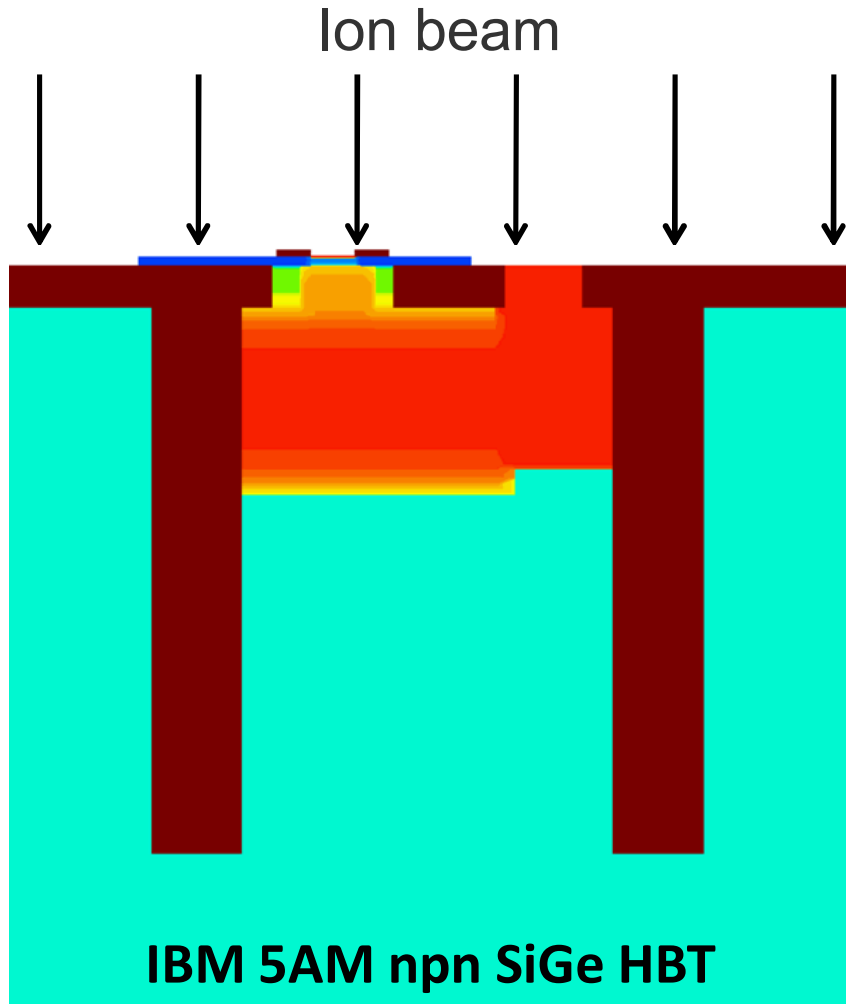
$$V_{\text{sub}} = -3 \text{ V (Case 3)}$$

- Same result was observed in two-photon pulsed laser testing

J. A. Pellish et al., IEEE Trans. Nucl. Sci., vol. 55, no. 6, pp. 2936-2942, Dec. 2008.

Difference in peak current results from non-zero V_{CB}

Heavy ion broadbeam transients



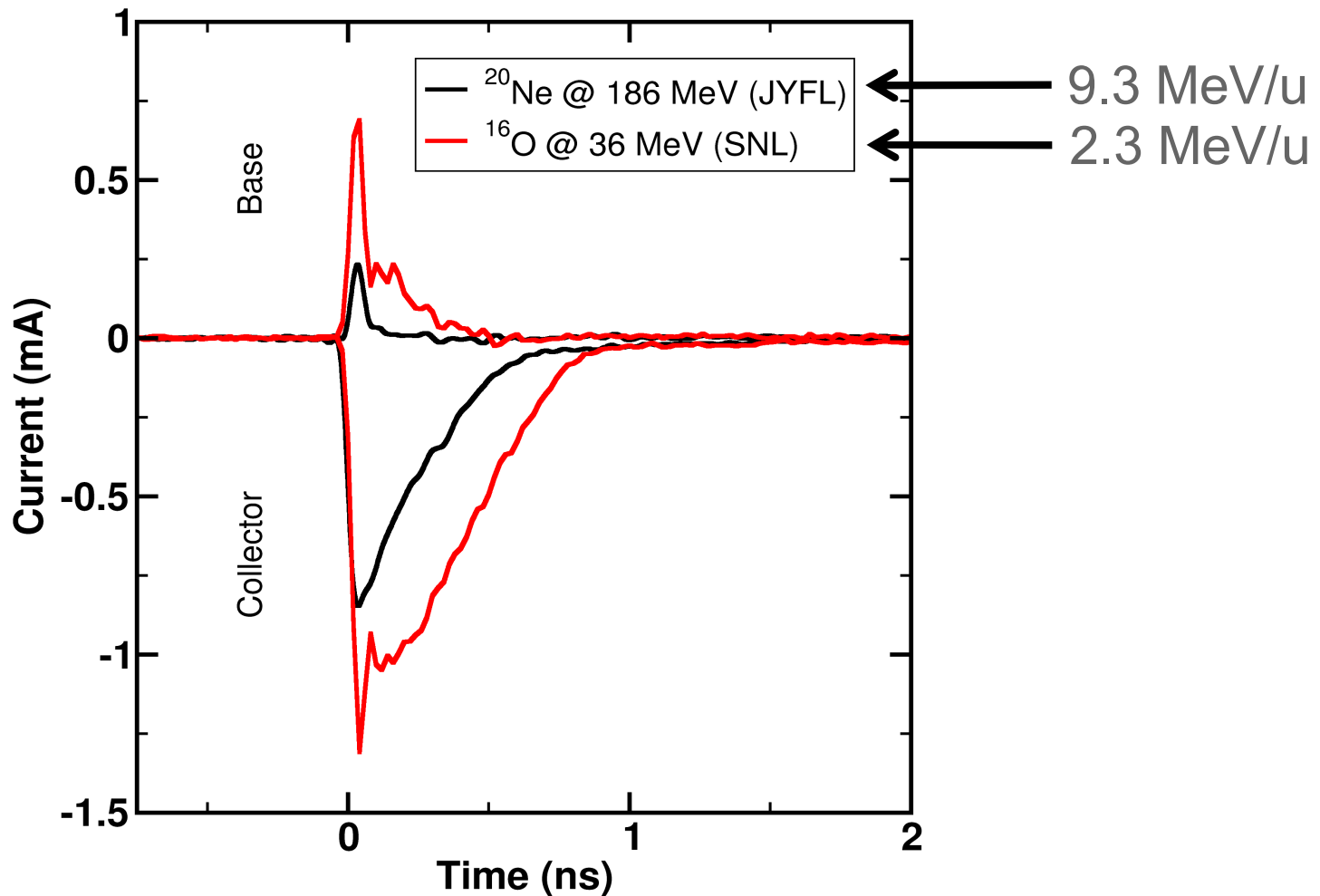
University of Jyväskylä
K-130 Cyclotron



No position correlation with
broadbeam irradiation

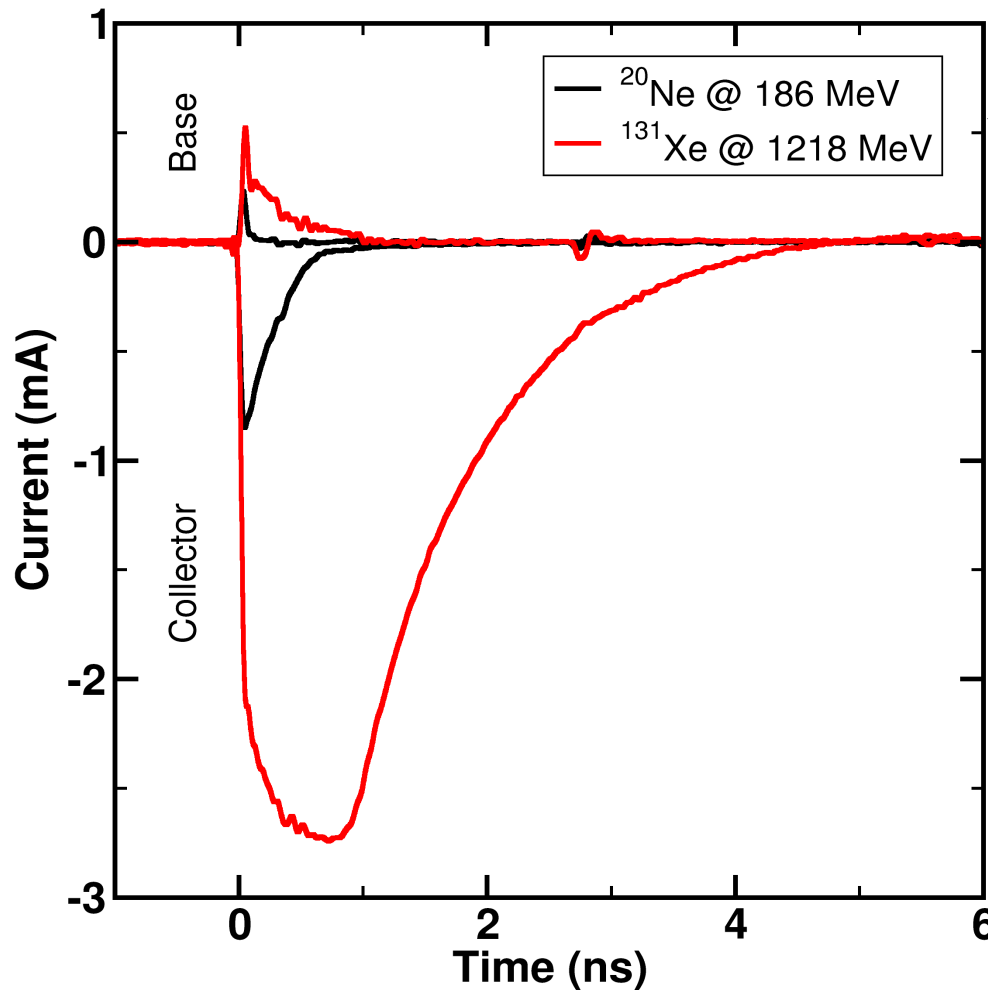
- Data collection at JYFL and GANIL
- 9.3 MeV/u cocktail including ^{20}Ne , ^{40}Ar , ^{82}Kr , and ^{131}Xe and 45.5 MeV/u ^{136}Xe

JYFL vs. SNL: LET scaling



^{20}Ne and ^{16}O transients are similar – related by LET

JYFL: LET extremes



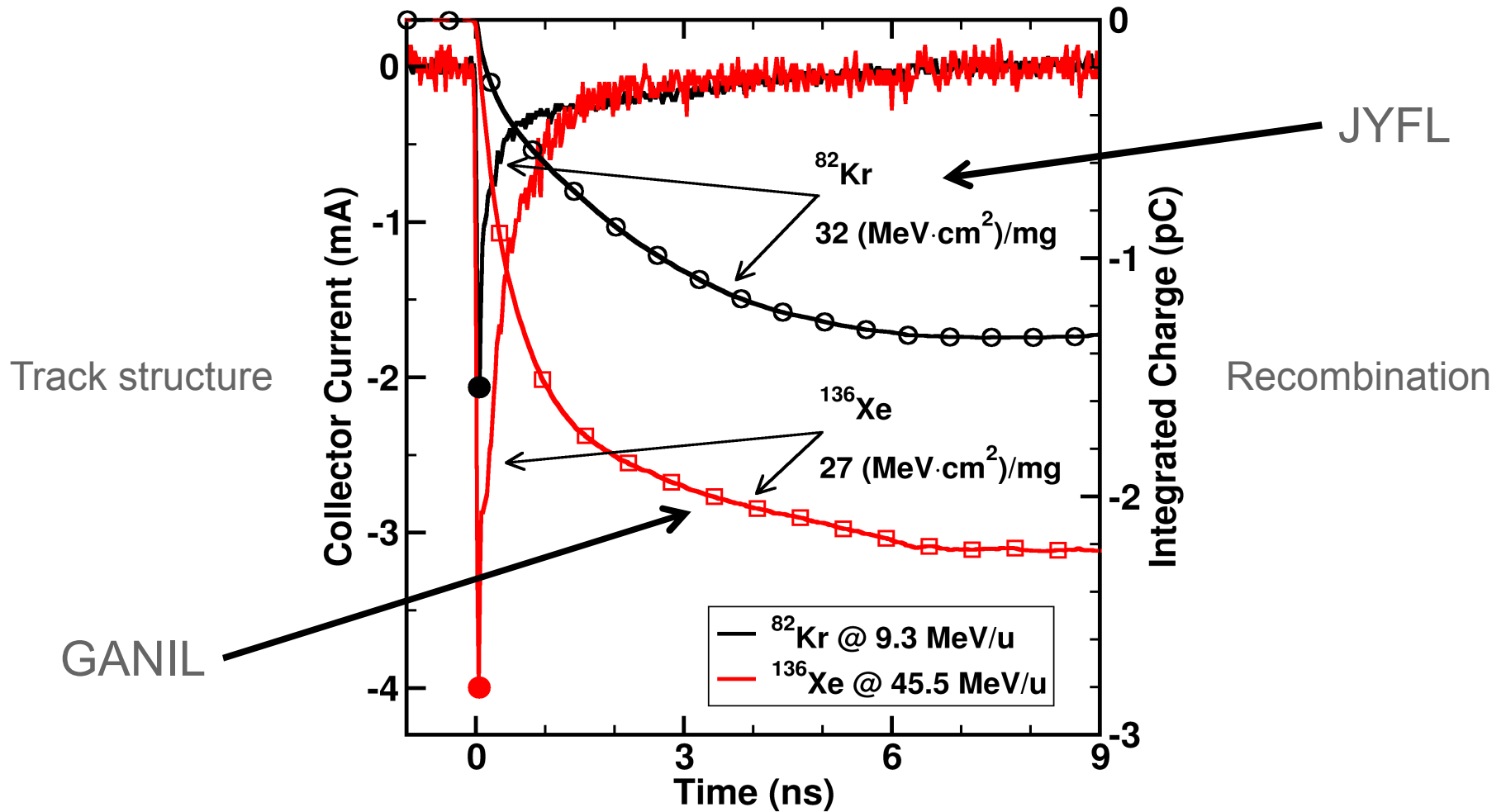
← 9.3 MeV/u

^{20}Ne LET
3.6 (MeV·cm²)/mg

^{131}Xe LET
60 (MeV·cm²)/mg

Position correlation made possible with microbeam data

JYFL vs. GANIL transients



Ma Similar LET values produce different transient responses ty



Conclusions

- Microbeam (SNL) transients reveal **position-dependent** heavy ion response
 - Unique response for different device regions
 - Unique response for different bias schemes
 - Similarities to TPA pulsed-laser data
- Broadbeam transients (JYFL and GANIL) provide **realistic** heavy ion response
 - Feedback using microbeam data
 - Overcome issues of LET and ion range with microbeam
 - **Angled ^{40}Ar data in full paper
- Data sets yield **first-order results**, suitable for CAD
CAD data for feedback